

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Russell et al.

Serial No.: To Be Assigned

Filed: Concurrently Herewith

For: CHEMICALLY ENHANCED FOCUSED ION BEAM MICRO-MACHINING OF COPPER

September 26, 2003

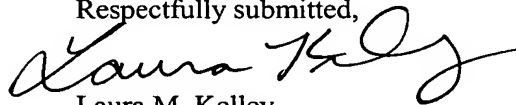
Mail Stop Patent Application  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Attached is a list of documents on form PTO-1449. Items 1-10 listed on the PTO-1449 were cited in parent application Serial No. 10/284,784, filed October 31, 2002. Since the benefit of this application is claimed under 35 U.S.C. § 120, no copies need to be furnished in accordance with 37 C.F.R. § 1.98(d); however, copies will be furnished on request. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Respectfully submitted,



Laura M. Kelley

Registration No. 48,441

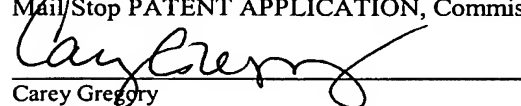
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Mail Stop PATENT APPLICATION, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

  
Carey Gregory

